

Supplementary Information

Structure-directing synthesis of porous CuO–SiO₂ nanocomposites using carbon nitride

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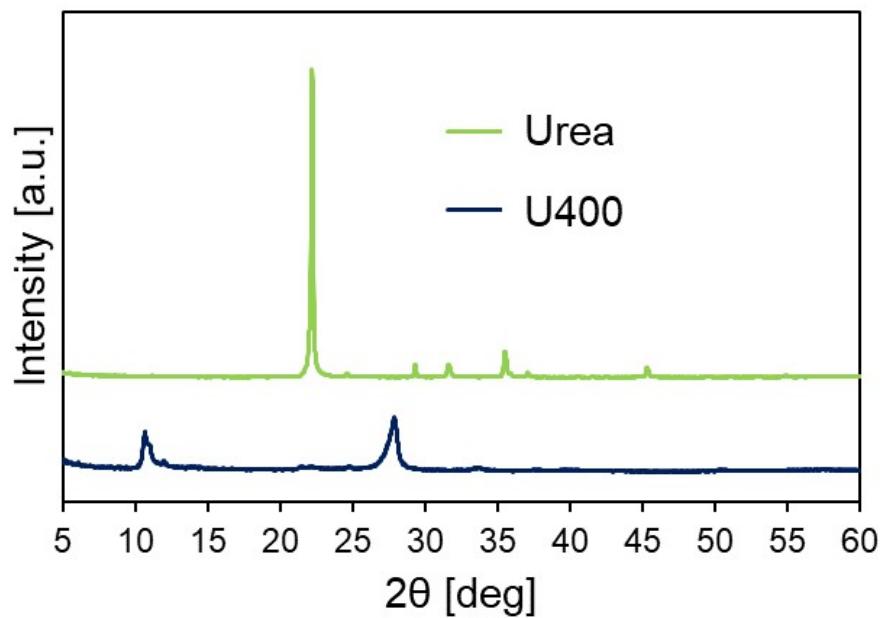


Fig. S1 XRD patterns for urea and U400.

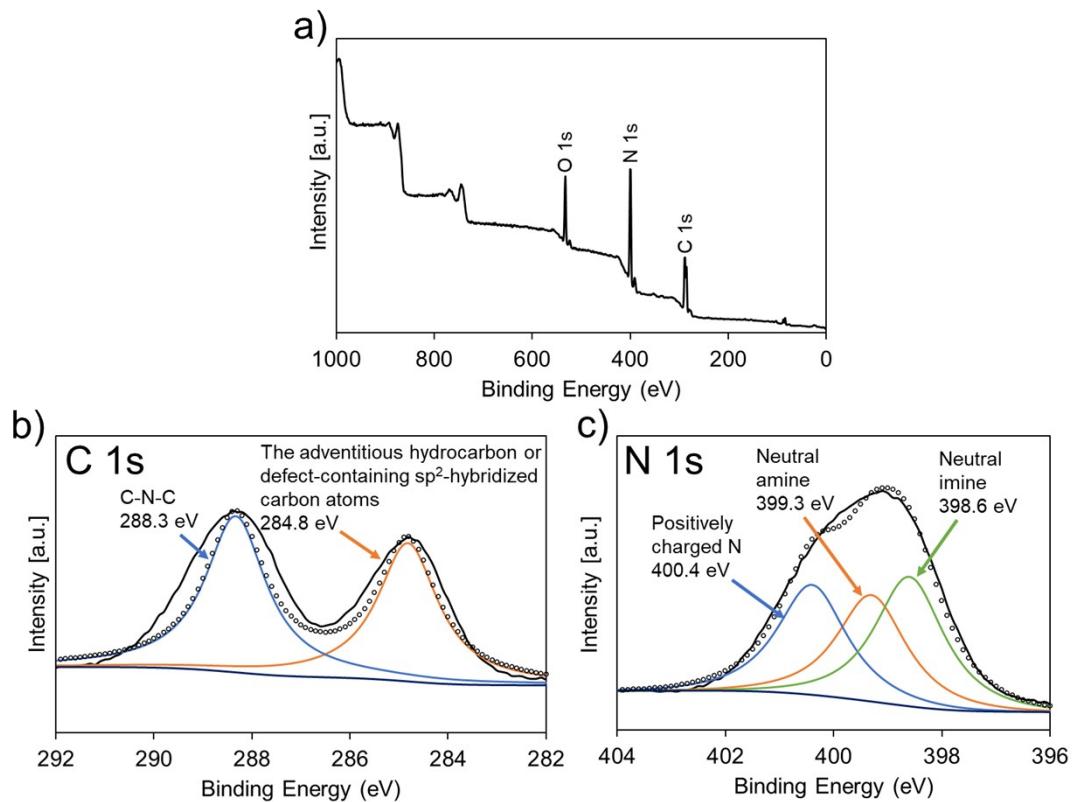


Fig. S2 a) XPS survey scan, and high-resolution XPS spectra in b) C 1s region and c) N 1s region for U400.

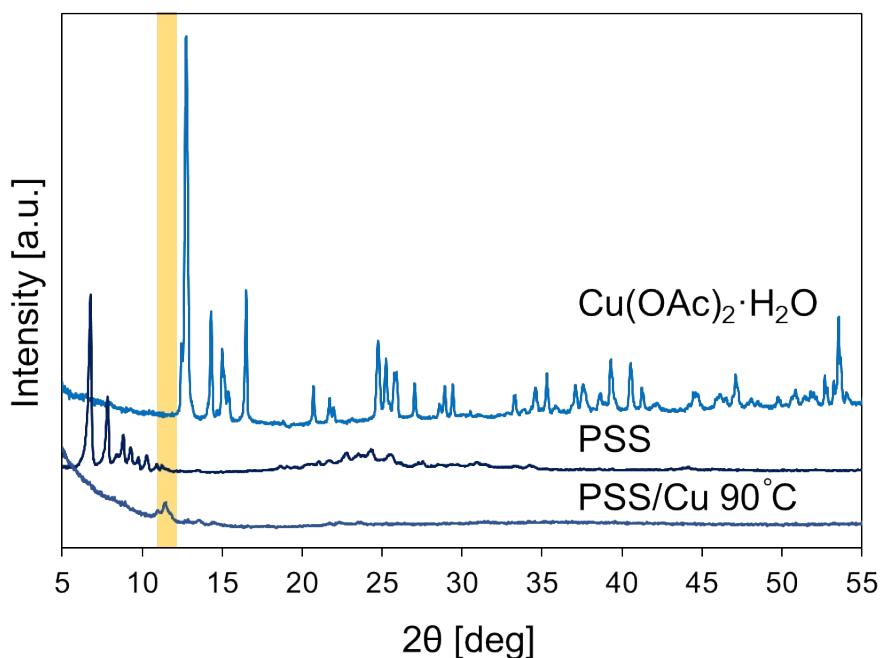


Fig. S3 XRD patterns for $\text{Cu}(\text{OAc})_2 \cdot \text{H}_2\text{O}$, PSS, and PSS/Cu 90°C.

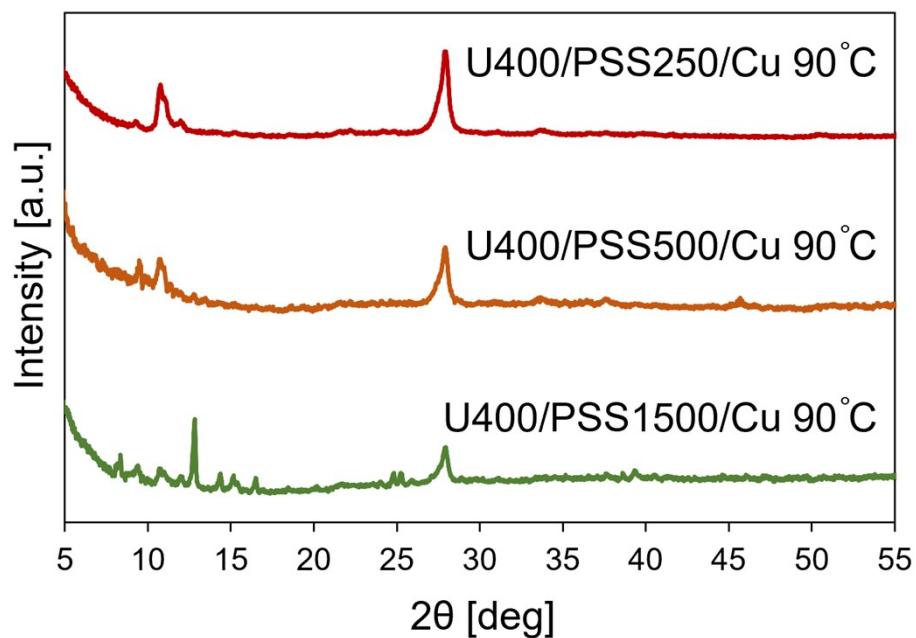


Fig. S4 XRD patterns for each U400/PSSx/Cu 90°C.

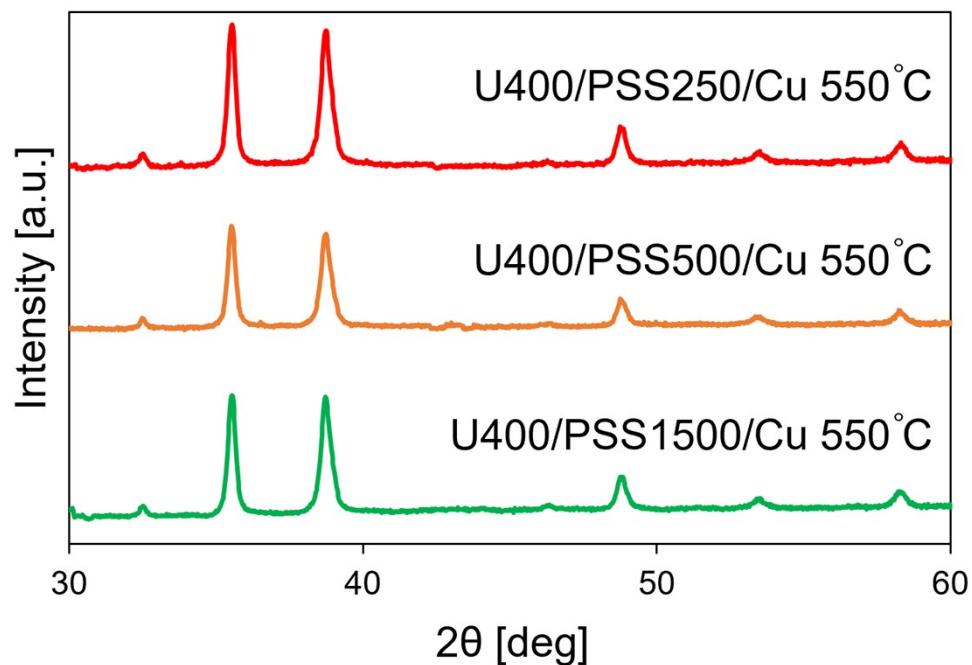


Fig. S5 XRD patterns for each U400/PSSx/Cu 550°C.

Table S1 Widths at half-maximum intensity of each peak in U400/PSS250/Cu 550°C and Cu(OAc)₂·H₂O 550°C.

	The peak at 2θ = 36° [°]	The peak at 2θ = 39° [°]
U400/PSS250/Cu 550°C	0.32	0.41
Cu(OAc) ₂ ·H ₂ O 550°C	0.29	0.31

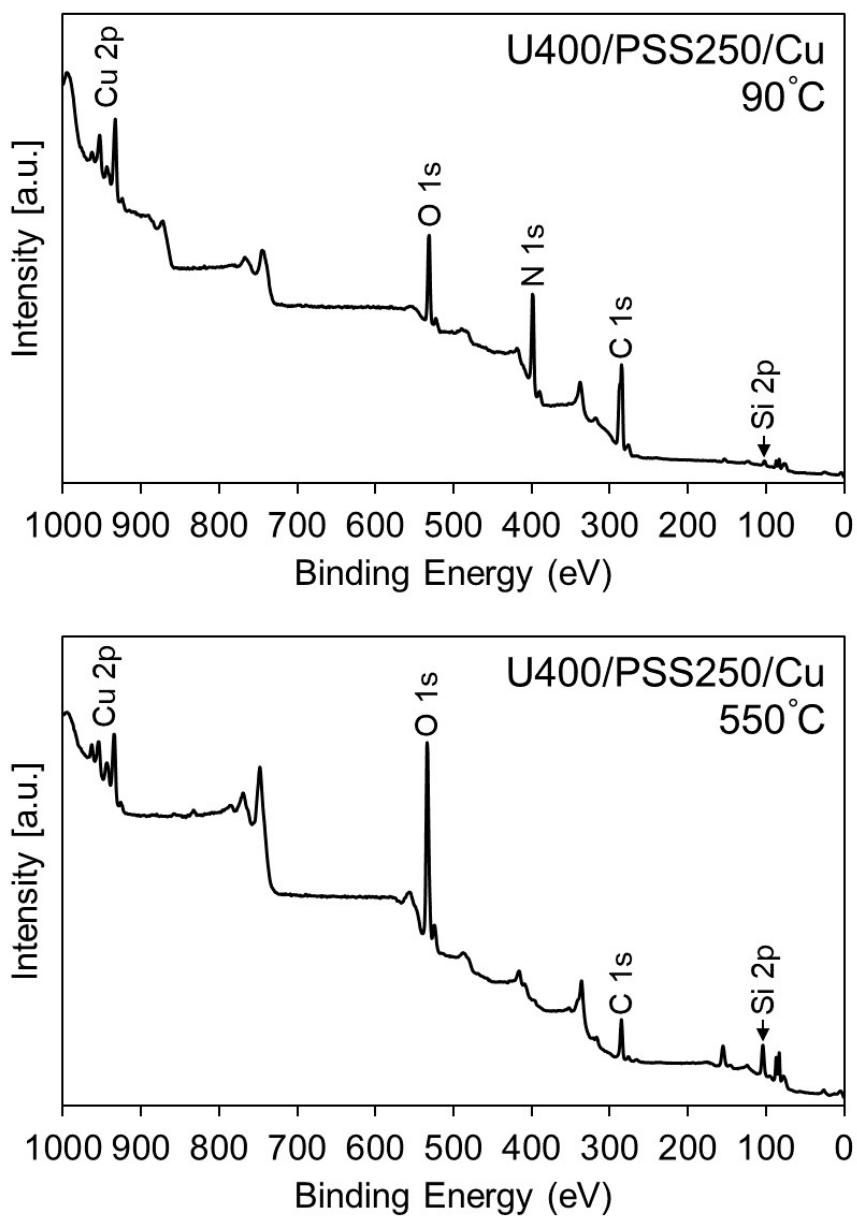


Fig. S6 XPS survey scan for U400/PSS250/Cu 90°C and U400/PSS250/Cu 550°C.

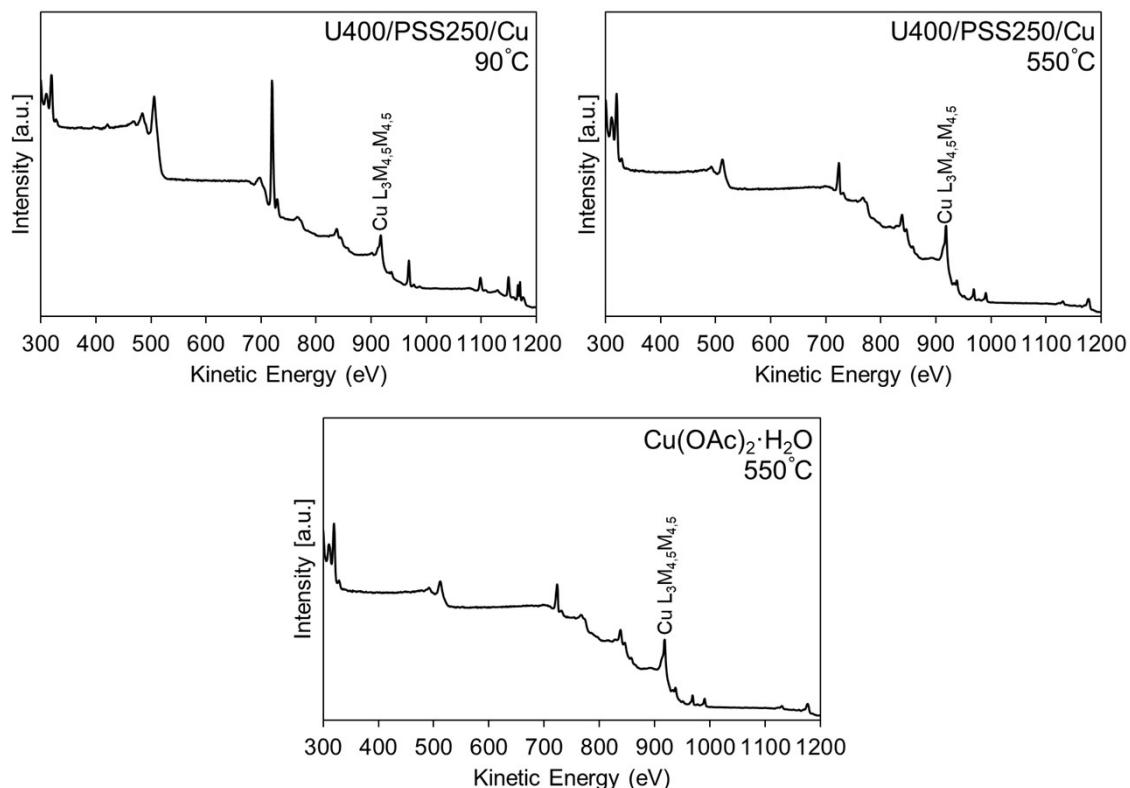


Fig. S7 XPS survey scan for U400/PSS250/Cu 90°C, U400/PSS250/Cu 550°C, and $\text{Cu(OAc)}_2 \cdot \text{H}_2\text{O}$ 550°C in kinetic energy scale.

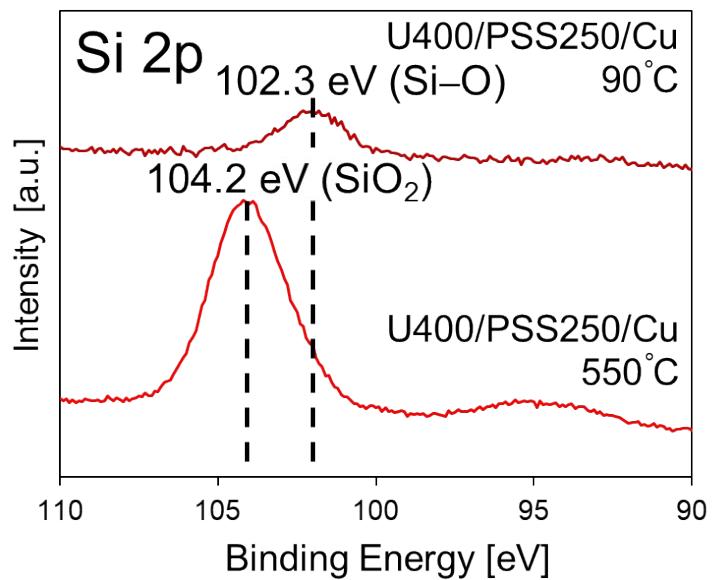


Fig. S8 High-resolution XPS spectra in Si 2p region for U400/PSS250/Cu 90°C and U400/PSS250/Cu 550°C.

Table S2 Calculated Auger parameters.

	Cu 2p _{3/2} photoelectron peak [eV]	Cu L ₃ M _{4,5} M _{4,5} Auger peak [eV]	Auger parameter [eV]
U400/PSS250/Cu 90°C	933.04	915.44	1848.5
U400/PSS250/Cu 550°C	934.08	917.70	1851.8
Cu(OAc) ₂ ·H ₂ O 550°C	933.59	918.05	1851.6

Table S3 The element ratio of Si and Cu in U400/PSS250/Cu 550°C.

	1	2	3	4	5	
Si [at%]	43.81	44.41	38.32	46.58	46.77	
Cu [at%]	56.19	55.59	61.68	53.42	53.23	
	6	7	8	9	10	Average
Si [at%]	46.86	48.01	50.91	45.75	47.33	45.9
Cu [at%]	53.14	51.99	49.09	54.25	52.67	54.1

Table S4 The element ratio of Si and Cu in U400/PSS500/Cu 550°C.

	1	2	3	4	5	
Si [at%]	36.77	38.36	29.14	39.30	44.05	
Cu [at%]	63.23	61.64	70.86	60.70	55.95	
	6	7	8	9	10	Average
Si [at%]	34.01	30.60	29.61	45.96	45.46	37.3
Cu [at%]	65.99	69.40	70.39	54.04	54.54	62.7

Table S5 The element ratio of Si and Cu in U400/PSS1500/Cu 550°C.

	1	2	3	4	5	
Si [at%]	53.07	48.86	48.00	41.55	44.20	
Cu [at%]	46.93	51.14	52.00	58.45	55.80	
	6	7	8	9	10	Average
Si [at%]	42.88	50.68	53.35	47.46	49.10	47.9
Cu [at%]	57.12	49.32	46.65	52.54	50.90	52.1

Table S6 Experimental yields of U400/PSSx/Cu 550°C and theoretical yields of CuO and SiO₂.

Product name	Precursors (Before calcination 550°C) [mg]	Products (After calcination 550°C) [mg]	Experimental Yield [%]	Theoretical yield of CuO and SiO ₂ [%]
U400/PSS250/Cu 550°C	987	115	11.7	15.5
U400/PSS500/Cu 550°C	1449	280	19.3	22.5
U400/PSS1500/Cu 550°C	1705	516	30.3	32.3

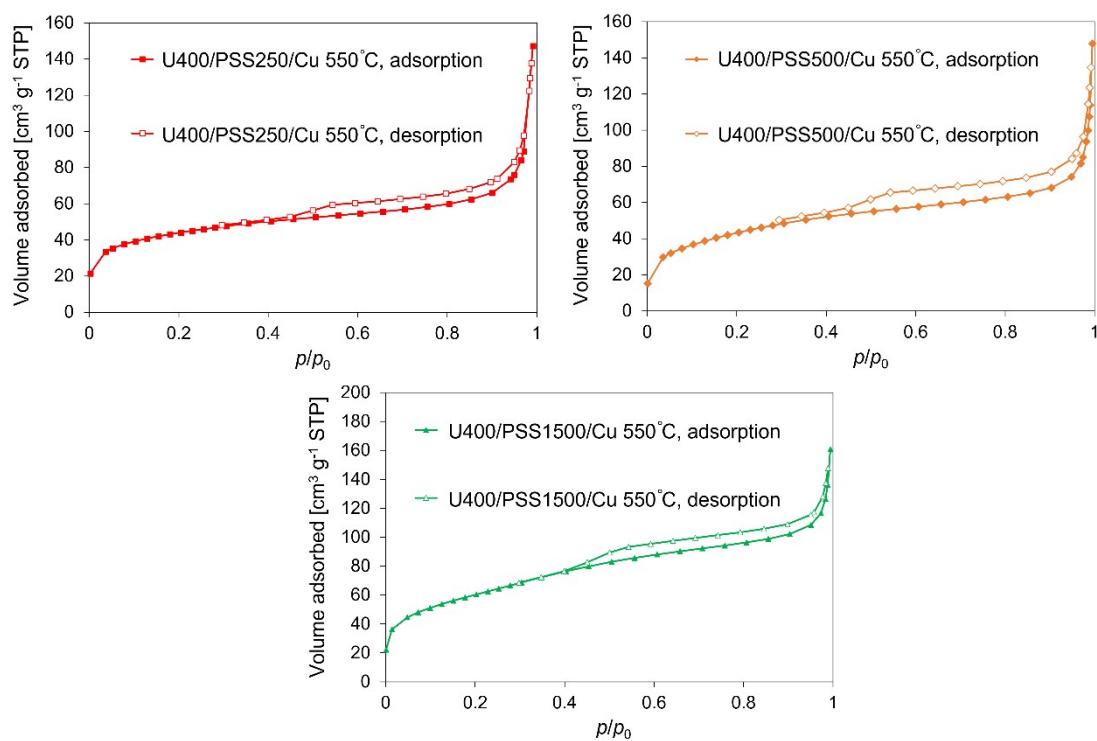


Fig. S9 N₂ adsorption–desorption isotherms of each U400/PSSx/Cu 550°C.

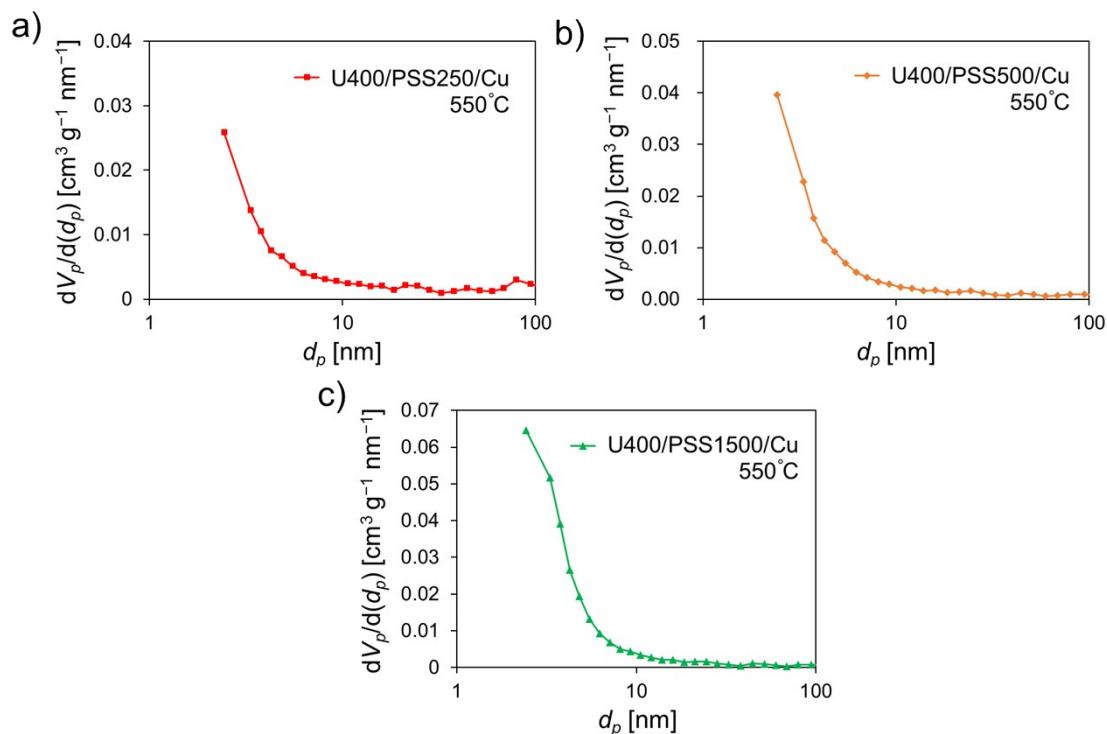


Fig. S10 BJH pore size distributions of a) U400/PSS250/Cu 550°C, b) U400/PSS500/Cu 550°C, and c) U400/PSS1500/Cu 550°C.

Table S7 Specific surface areas of each material.

Specific surface area [$\text{m}^2 \text{g}^{-1}$]	
U400/PSS250/Cu 550°C	157
U400/PSS500/Cu 550°C	153
U400/PSS1500/Cu 550°C	214
$\text{Cu(OAc)}_2 \cdot \text{H}_2\text{O}$ 550°C	1

Table S8 Comparative table from the literature in porosity.

	Method	Specific surface area [m ² g ⁻¹]	Ref.
CuO nanochains	Wet chemical route using polyethylene glycol as a soft template	123.1	1
CuO nanosheets clusters	Hydrothermal method with/without surfactants	75.40, 95.31, 93.87	2
CuO hollow microspheres	Carbon spheres used as templates	74.81	3
Porous CuO	Calcination of metal–organic frameworks	69.57, 89.18	4
CuO ultrathin nanobelts	Wet chemical method combined with a fast calcination strategy	109.13	5
Mesoporous CuO dandelion Structures	Hydrothermal route	325	6
Porous CuO	Calcination process via the chemical solution deposition to prepare the copper oxalate precursor	165, 193, 295	7
CuO/SiO ₂ composites	Solution exchange of wet silica gel (CuO content: 30 wt%)	158	8
Hollow CuO@SiO ₂ spheres	Template method using Cu@C composite as a hard template (Cu content: 26 wt%)	85	9
Porous CuO–SiO ₂ nanocomposites	Structure-directing synthesis via calcination	153, 157, 214	In this study

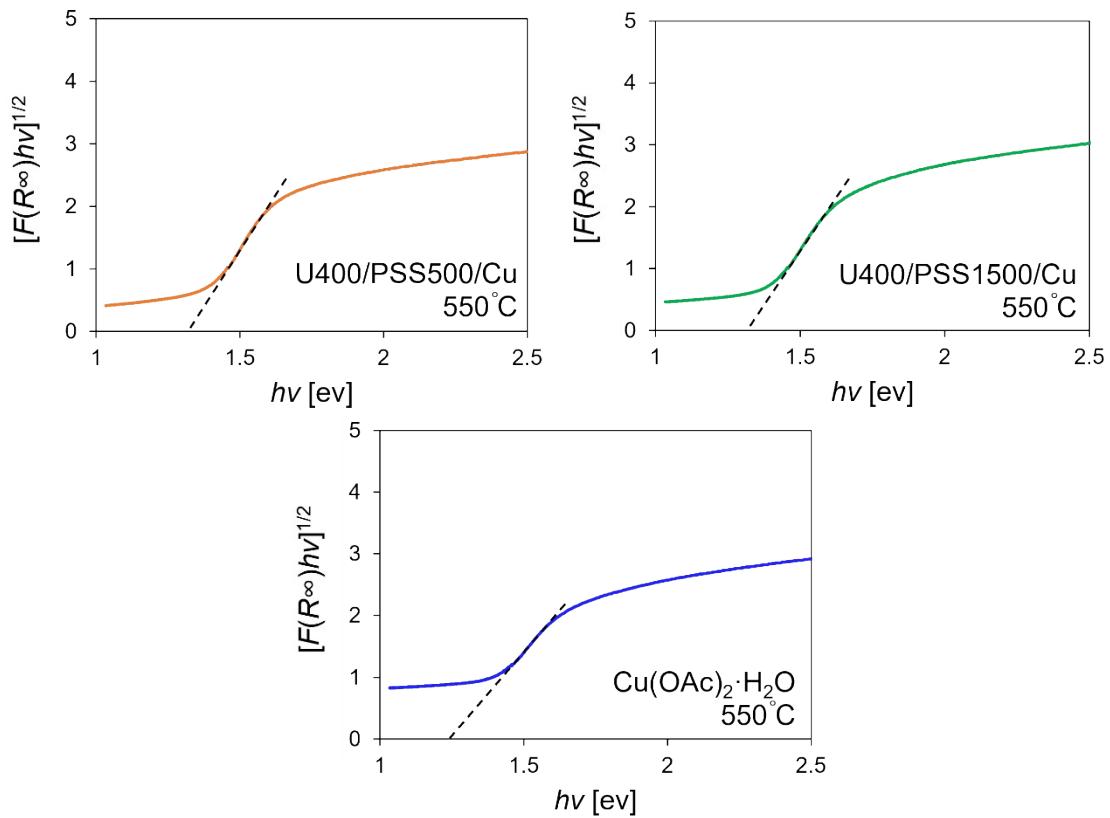


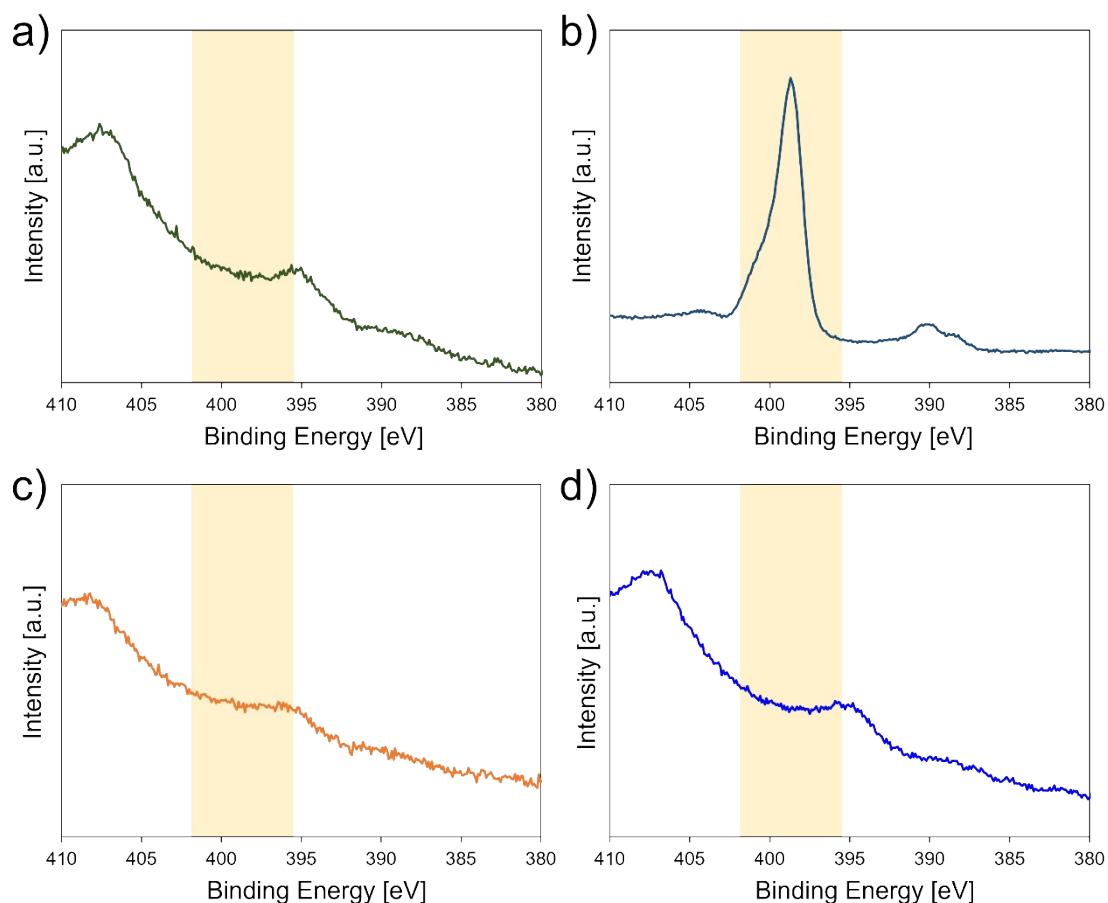
Fig. S11 Optical band gaps of U400/PSS500/Cu 550°C, U400/PSS1500/Cu 550°C, and Cu(OAc)₂·H₂O 550°C determined with the plots of $[F(R^\infty)hv]^{1/2}$ versus photon energy ($h\nu$).

Table S9 Comparative table from the literature in band gap.

	Band gap [eV]	Ref.
CuO–ZnO core–shell nanowire	1.5–1.6	10
CuO@TiO ₂ heterostructure composite	2.35	11
CuO/CuFe ₂ O ₄ nanocomposites	1.37–1.72	12
Core/shell nanoparticles of SiO ₂ @CuO	2.63–4.20	13
CuO/SiO ₂ monolith	1.33	14
Porous CuO–SiO ₂	1.3	In this study

Table S10 The element ratio of Si and Cu in PSS/Cu 550°C.

	1	2	3	4	5	
Si [at%]	0	0	0	11.48	7.39	
Cu [at%]	100	100	100	88.52	92.61	
	6	7	8	9	10	Average
Si [at%]	0	0	6.61	10.06	4.77	4.03
Cu [at%]	100	100	93.39	89.94	95.23	95.97

**Fig. S12** High-resolution XPS spectra in the N 1s region for a) U400/Cu 550°C, b) U400/PSS 550°C, c) U400/PSS500/Cu 550°C, and d) the background (Cu(OAc)₂·H₂O 550°C).

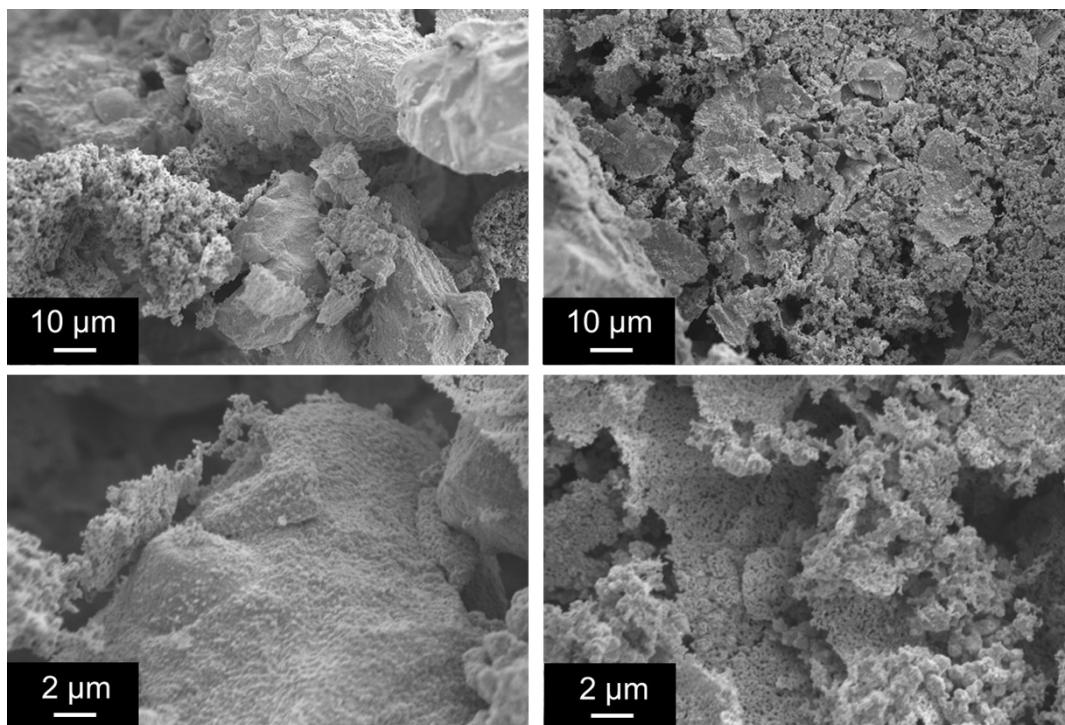


Fig. S13 SEM images of $\text{Cu}(\text{OAc})_2 \cdot \text{H}_2\text{O}$ 550°C.

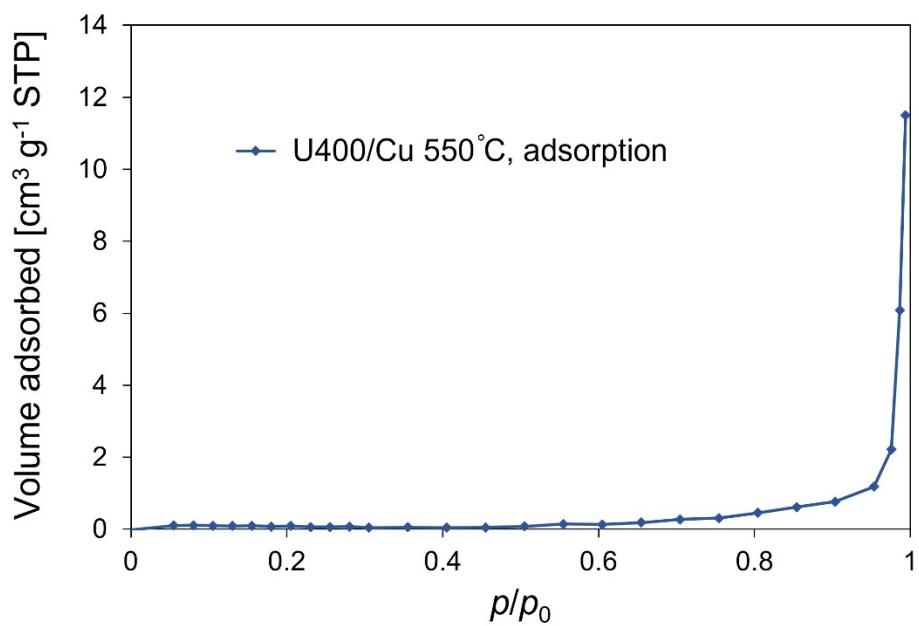


Fig. S14 The N_2 adsorption isotherm of U400/Cu 550°C.

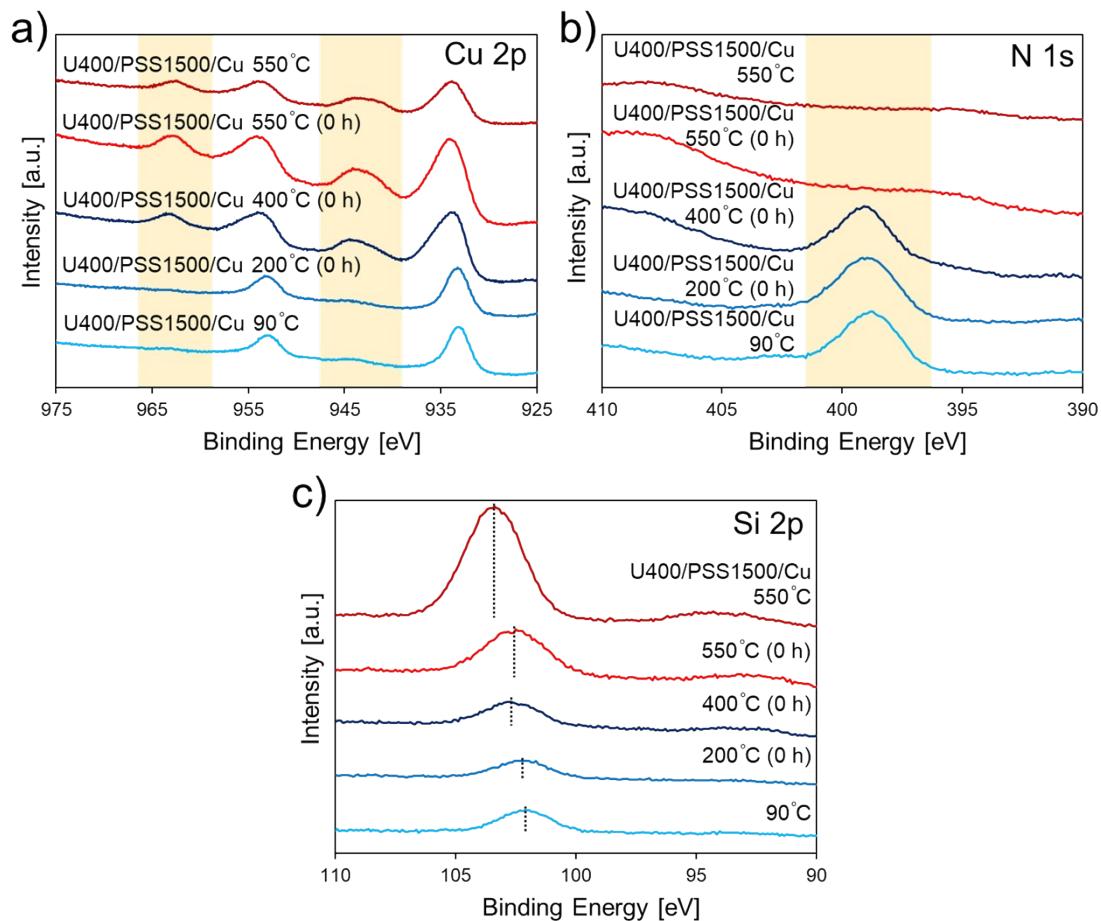


Fig. S15 High-resolution XPS spectra in a) Cu 2p region, b) N 1s region, and c) Si 2p region for U400/PSS1500/Cu 90°C and the samples obtained by calcinating U400/PSS1500/Cu 90°C at different conditions.

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